Docket No. TRANSMITTAL OF FORMAL DRAWINGS YOR920030293US1 (16818) Kang Su Choe, et al. In Re Application Of: MAY 1 0 2004 Serial No. Feling Date Confirmation No. Examiner Art Unit 10/674,647 September 30, 2003 Unassigned Unassigned 1753 THIN BURIED OXIDES BY LOW-DOSE OXYGEN IMPLANTATION INTO MODIFIED SILICON Invention: Address to: **Commissioner for Patents** P.O. Box 1450 Alexandria, VA 22313-1450 Transmitted herewith are: 6 sheets of formal drawing(s) for this application. X Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c).

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May 7, 2004 Dated:

I certify that this document and attached formal drawings are being deposited on 5/7/2004 with the

U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Commissioner for Patents, P.O. Box

1450, Alexandria, VA 22313-1450.

Signature of Person Mailing Correspondence

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